



Docket No.: M4065.0159/P159-B
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Li Li, et al

Confirmation No.: 5524

Application No.: 09/939,651

Group Art Unit: 1765

Filed: August 28, 2001

Examiner: B. Tran

For: METHOD OF CONTROLLING
STRIATIONS AND CD LOSS IN
CONTACT OXIDE ETCH

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GROUP 1700

AMENDMENT

Box Non-Fee Amendment
Commissioner for Patents
Washington, DC 20231

#8 B
4/15/03
mw

Dear Sir:

In response to the Office Action dated January 14, 2003 (Paper No. 6), please
amend the above-identified U.S. patent application as follows:

In the Claims

Please amend claim 92 as shown in the Replacement Claims: